EUROPEAN PATENT OFFICE

Patent Abstracts of Japan

PUBLICATION NUMBER

08183621

PUBLICATION DATE

16-07-96

APPLICATION DATE

27-12-94

APPLICATION NUMBER

: 06325016

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INT.CL.

C03B 8/04 C01B 33/18 C03B 19/06 C03B 20/00 C03C 3/06 // C30B 15/10 H01L

21/22

TITLE

PRODUCTION OF HIGH-PURITY HIGHLY HEAT RESISTANT SILICA GLASS

ABSTRACT:

PURPOSE: To obtain silica glass useful for a furnace core tube, a crucible, a liq. crystal panel, etc., by hydrolyzing a silicon compd. in an oxyhydrogen flame, forming a silica porous body grown in the axial direction of a target and heating it under specified conditions.

CONSTITUTION: A silicon compd. such as purified $SiCl_4$ or alkyl silicate is used as starting material and this starting material is vaporized and hydrolyzed in an oxyhydrogen flame. The resultant silica powder is deposited on a target and grown in the axial direction to form a high purity silica porous body and transparent silica glass is produced by heating the porous body. At this time, the porous body is heated at $\geq 1,300^{\circ}C$ in an atmosphere contg. gaseous CO so that the bulk density is regulated to $\geq 1.5 g/cm^3$ and the objective silica glass having ≤ 10 ppm concn. of OH and $\leq 10^{13.0}P$ viscosity at 1,200°C is obtd. The concn. of each of all metallic impurities in this silica glass is ≤ 50 ppb.

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